



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 10, 2026	
IGI Report Number	LG772639941
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.14 - 8.19 X 4.97 MM

GRADING RESULTS

Carat Weight	2.05 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	IDEAL

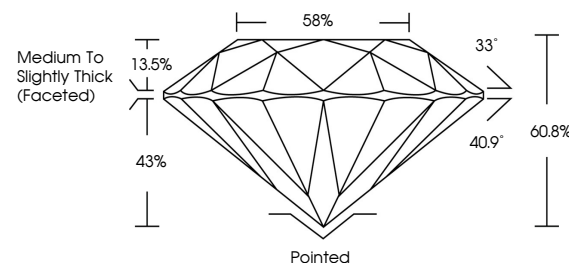
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG772639941

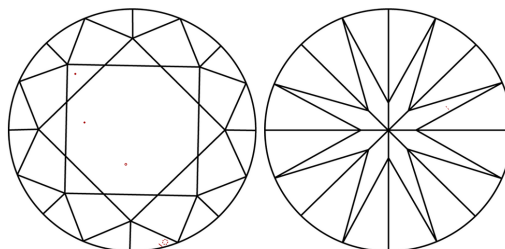
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG772639941
Report verification at igi.org

PROPORTIONS

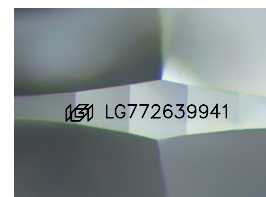


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

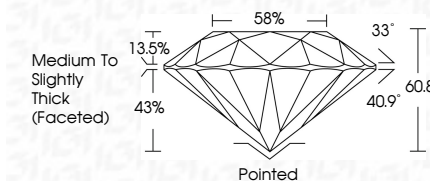
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Fluorescence	NONE
Inscription(s)	(LS) LG772639941
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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www.igi.org

February 10, 2025	2.05 CARATS
Report No. LG77239941	E
ROUND BRILLIANT	VS 1
	IDEAL
	50.6%
	58%
	Medium to Slightly Thick (Faceted)
	Polished
	EXCELLENT
	EXCELLENT
	NONE
	#691LG77239941
Comments:	
This Laboratory Grown Diamond was analyzed by the Thermal Vapor Deposition (TVD) growth process.	
Type IIG	